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**INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT**

Applicant: YAMASAKI et al.	
Appln. No.: 10/673,648	
Filing Date: September 30, 2003	
Examiner: Berry, R.R.	Group Art Unit: 2818

Date: January 5, 2005

Page 1 of 1

**U.S. PATENT DOCUMENTS**

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
MP	AR	6,444,263 B1	09/2002	Paranjpe et al.	427	250	
	BR						
	CR						
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
	MR								
	NR								
	OR								
	PR								
	QR								
	RR								
	SR								
	TR								
	UR								
	VR								

**OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

MP	WR	Kaplan et al., "The Deposition of Molybdenum and Tungsten Films from Vapor Decomposition of Carbonyls," Journal of the Electrochemical Society USA, Vol. 117, No. 5, May 1970 (1970-05), pages 693-700			X
	XR				
	YR				
	ZR				

Examiner RAJ Date Considered: 2-4-05

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.